



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Initial application of

: **Confirmation No. 4423**

Tomohiro OKUMURA et al.

: Docket No. 2001-1089A

Serial No. 09/918,823

: Group Art Unit 2821

Filed August 1, 2001

: Examiner T. Phan

PLASMA PROCESSING METHOD
AND APPARATUS THEREOF

THE COMMISSIONER IS AUTHORIZED
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Sir:

Attached hereto is a check in the amount of \$1,130.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time \$950.00

Information Disclosure Statement \$180.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

Tomohiro OKUMURA et al.

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